# Author Correction: Scalable high-precision tuning of photonic resonators by resonant cavity-enhanced photoelectrochemical etching

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The original version of this Article omitted the fourth author, Sara Ducci from Matériaux et Phénomènes Quantiques, Université Paris Diderot, CNRS UMR 7162, Sorbonne Paris-Cité, 10 rue Alice Domon et Léonie Duquet, Paris 75013, France. This mistake has been corrected in both the HTML and PDF versions of the Article.

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